

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/598,502 Confirmation No. 6549  
Applicant : Yuichiro Nakamura et al.  
371 Filed : September 1, 2006  
Art Unit : 1793  
Examiner : Mark L. Shevin  
Customer No. : 00270  
Title : SPUTTERING TARGET WITH FEW SURFACE DEFECTS,  
AND SURFACE PROCESSING METHOD THEREOF

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment timely submitted in response to a non-final Office Action dated June 17, 2010. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.